

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Israel, et al.
Title: OPTIMAL SILICON DIOXIDE PROTECTION LAYER THICKNESS FOR SILVER LAMP REFLECTOR
Serial No.: Not Assigned Yet
Art Unit: Not Assigned Yet
Filing Date: Herewith
Examiner: Not Assigned Yet
Date: August 1, 2003
Atty. Dkt. No.: LDHQ10695-3 (GECZ 2 00083-2-3)

INFORMATION DISCLOSURE STATEMENT

Mail Stop – Patent Application

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

The following are submitted in the above application in compliance with 37 CFR 1.97 and 37 CFR 1.98.

- [X] 1. A list of documents on Form PTO-1449 or Substitute together with copies of each identified document and a translation thereof or a concise explanation of each non-English language document or a Search Report or communication from a non-US patent office or an International Search Report from an International Searching Authority for a patent application filed via the Patent Cooperation Treaty or document(s) cited in the application or the priority application.

This paper is submitted in accordance with:

- [X] 2. 37 CFR 1.97(b): [within three months of national, non-CPA filing, prior to first Office Action, on the merits, or prior to first office action after filing an RCE]
- [] 3. 37 CFR 1.97(c): [before Final Office Action, Allowance, or other action closing prosecution, whichever is earlier]; and
- [] a. The required Certification made in item 5 below; or
- [] b. The \$180.00 fee specified in 37 CFR 1.17(p) for submission of this Information Disclosure Statement is authorized in item 6 below.

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 as Express Mail No. EV341149075US on Aug. 1, 2003 and is addressed to Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, on the date indicated below.

By Cheryl Kobylinaki
Cheryl Kobylinaki

Date: 8/1/2003

☐ 4. 37 CFR 1.97(d): [on or before issue fee payment]; and

a) The required Certification is stated in item 5 below; and

b) The \$180.00 fee specified in 37 C.F.R. 1.17(p) for submission of this Information Disclosure Statement is authorized in item 6 below.

☐ 5. Certification

☐ a. Each item of information contained in this Statement was first cited in any communication from a foreign patent office in a counterpart foreign patent application not more than three months prior to the filing of this Statement; or

☐ b. No item of information contained in this Statement was cited in a communication from a foreign patent office in a counterpart foreign patent application and, to the knowledge of the person signing this document after making reasonable inquiry, no item of information contained in this Statement was known to any individual designated in 37 CFR 1.56(c) more than three (3) months prior to the filing date of this Statement.

☐ 6. Payment of all applicable fees:

- Please charge all applicable fees associated with the submittal of this Information Disclosure Statement to Deposit Account No. _____.
- Enclosed is a check in the amount of \$_____ in payment of all applicable fees associated with the submittal of this Information Disclosure Statement.

This document is submitted in duplicate.

Respectfully submitted,

**FAY, SHARPE, FAGAN,
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| Subst. Form PTO-1449 APPLICANT'S(S') INFORMATION DISCLOSURE STATEMENT | Atty. Docket No.: LDHQ10695-3 GECZ 2 00083-2-3 | Serial No.: Not Assigned Yet |
| | Applicant(s): Israel, et al. | |
| | Filing Date: Herewith | Group: Not Assigned Yet |

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Examiner:

Date Considered:

* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if in conformance and not considered. Include copy of this form with next communication to applicant.

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